




PATENT
Attorney Docket No. A-70092/RMA/JML (469090-14)
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: KAJIWARA, et al.	Examiner: MORGAN, EILEEN P
Serial No.: 09/874,174	Group Art Unit: 3723
Filing Date: 4 JUNE 2001	<u>CERTIFICATE OF MAILING</u>
For: CHEMICAL MECHANICAL POLISHING APPARATUS AND METHOD HAVING A RETAINING RING WITH A CONTOURED SURFACE	I hereby certify that this correspondence and its listed enclosures is being deposited with the United States Postal Service as First Class Mail addressed to Commissioner for Patents: P.O. Box 1450; Alexandria, VA 22313-1450 on <u>NOVEMBER 10, 2003</u>
	Signed  Maria Giganovich

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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TECHNOLOGY CENTER R3700

Sir:

Following is Applicants' response to the Restriction Requirement mailed 10 SEPTEMBER 2003. The response is accompanied by a petition for a one-month extension of time and the requisite fee. A response is therefore due 10 NOVEMBER 2003, making this a timely response. Please amend the application as indicated on the following pages, and consider the remarks herein. Enclosed is our check to cover the cost of added claims not already paid for. While Applicant believes that no further fees are due at this time, the Commissioner is authorized to charge any fees that may be due as a result of filing this amendment, including additional claims fees not already paid for, or other fees that have not been separately paid, to Deposit Account 50-2319 (Order No. A-70092/RMA/JML (469090-14)).

11/17/2003 JBALINAN 00000078 09874174

01 FC:1201
02 FC:1202

86.00 DP
180.00 DP